

X axis | XP-780.XS/K Piezo Nanopositioning Stages



- Max stroke to 200µm
- Aperture: 25×25mm
- Max load to 5kg
- Open/closed loop is optional
- Available UHV version

Applications >>

- Laser interference
- Nano-measurement
- Nano imprint
- Scanning microscope
- Nano-measurement
- Nano imprint
- Nano-lithography, biotechnology
- Nanometer manipulation technology



Tel: +86-451-86268790 Err Fax: +86-451-86267847 We

Email: info@coremorrow.com Web: www.coremorrow.com

Harbin Core Tomorrow Science & Technology Co., Ltd.

Headquarters: Building I2, No.191 Xuefu Road, Nangang District, Harbin Shanghai Office: Building 2, No.608 Shengxia Road, Pudong District, Shanghai

Introduction

XP-780 piezo scanner adopts amplification mechanism, flexible hinge design and high-reliability piezo actuator to realize displacement of X-axis up to 200 μ m, and could be configured with closed-loop sensor for highprecision scanning and positioning. The size of aperture is 25mm x 25mm. It could realize 2 or 3 axes motion by superimposing.



Make Your Motion and Control More Accurate!

Technical Data >>

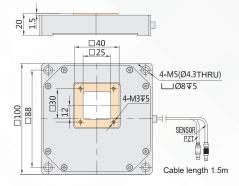
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Type S-Closed loop K-Open loop	XP-780.XS	XP-780.XK	Units
Active axes	Х	Х	
Travel range(0~120V)	160	160	µm±10%
Travel range(0~150V)	200	200	µm±10%
Sensor	SGS	-	
Aperture	25×25	25×25	mm
Closed/open loop resolution	5.5	2	nm
Closed-loop linearity	0.1	-	%F.S.
Repeatability	0.05	-	%F.S.
Pitch/yaw/roll	<50	<50	µrad
Push/pull force	80/40	80/40	Ν
Stiffness	0.5	0.5	N/µm±20%
Unloaded resonant frequency	200	200	kHz±20%
Closed/open-loop unloaded step time	20	5	ms±20%
Load capacity	5	5	kg
El. capacitance	11	11	μF±20%
Operating temperature ^[1]	-20~80	-20~80	°C
Material	Aluminum	Aluminum	
Size(L×W×H)	100×100×20	100×100×20	mm
Mass	240	240	g±5%
Cable length ^[2]	1.5	1.5	m±10mm

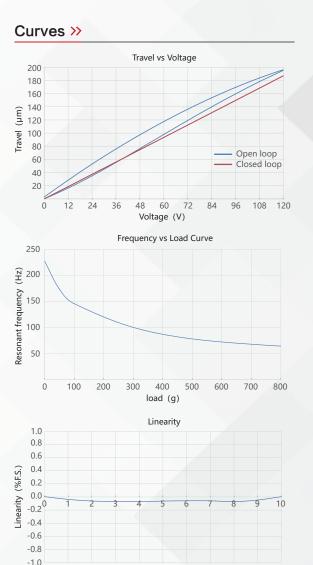
Note: Max driving voltage could be -20V~150V, 0~120V is recommended for long-term and high-reliable operation.Unless otherwise specified, the above parameters are measured at room temperature about 25° C.

[1] Custom ultralow temperature and ultrahigh vacuum versions are available.[2] Custom cable length and connector is available.

Note: The parallelism of the moving platform is about $20\mu m$, and the roughness is about 1.6 to 3.2. Please contact the sales engineer for confirmation before purchase.

Drawing >>





Disclaimer: The data here are typical, only for reference. Some variations will occur for different batch.

Input (V)

Recommended Controllers >>



E01.D1 LCD, membrane button, up to 625mA RS-232/RS-422/USB interface Software secondary development



E53 Small size, 60mA RS-232/RS-422/USB interface Software secondary development



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